

Notice of References Cited	Application/Control No. 10/661,949	Applicant(s)/Patent Under Reexamination LIN, CHIH-HAO	
	Examiner Chuck O. Kendall	Art Unit 2192	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,711,736	03-2004	Lo et al.	717/168
*	B	US-2004/0015941	01-2004	Sekine, Norihisa	717/168
*	C	US-6,594,757	07-2003	Martinez, Jesus A.	713/2
*	D	US-2005/0257215	11-2005	Denby et al.	717/172
*	E	US-6,279,153	08-2001	Bi et al.	717/171
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.